

GR 00 P 1583



1762

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Klaus Lowack et al.

Applic. No. : 09/817,963

Filed : March 27, 2001

Title : Method For The Metalization Of An Insulator  
And/Or A Dielectric

Examiner : Brian K. Talbot

Group Art Unit : 1762

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S i r :

Responsive to the Office action dated March 8, 2002 kindly  
amend the above-identified application as follows:

In the Specification:

On page 3, lines 18-21, replace the paragraph with:

-- The object and subject of the invention are achieved by a  
process for the metallization of at least one insulating layer